IN THE UNITED STATES PATENT AND TRADEMARK OFFICE PATENT Application of: Koichiro TANAKA Art Unit: 2877 Application Serial No. 09/481,396 Examiner A. Rodriguez Filed: January 12, 2000 CERTIFICATE OF MAILING LASER IRRADIATION APPARATUS ) For: certify correspondence is being deposit d with **AMENDMENT** the United States Postal Servic sufficient postage as First Class Mail in an envelope addressed to: Assistant **Commissioner for Patents** Commissioner for Patents, Washington, Washington, D.C. 20231

Sir:

Responsive to the Office Action dated February 28, 2001, the period for response having been extended one (1) month until June 28, 2001, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

## **IN THE CLAIMS:**

Please cancel claim 1 without prejudice or disclaimer to the subject matter recited therein.

Please amend claims 2-4 as follows. Attached hereto is a marked-up version of the amended claims.

(Amended) A laser irradiation apparatus comprising:

a beam generating unit;

a lens for dividing a laser beam in one direction;

an optical system for overlapping divided laser beams; and

a slit located between said beam generating unit and said lens for forming

edges in the laser beam, which is vertical to said direction.

(Amended) A laser irradiation apparatus comprising:

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